| Electronic Patent Application Fee Transmittal | | | | | | | |
|---|--|----------|----------|--------|-------------------------|--|--|
| Application Number: | 10786807 | | | | | | |
| Filing Date: | 25-Feb-2004 | | | | | | |
| Title of Invention: | Method for improving semiconductor wafer test accuracy | | | | | | |
| First Named Inventor/Applicant Name: | Hui-Mei Chen | | | | | | |
| Filer: | Dennis Alan Duchene/Lynne Craig | | | | | | |
| Attorney Docket Number: | 085027-0106 | | | | | | |
| Filed as Large Entity | | | | | | | |
| Utility under 35 USC 111(a) Filing Fees | | | | | | | |
| Description | | Fee Code | Quantity | Amount | Sub-Total in USD(\$) | | |
| Basic Filing: | | | | | | | |
| Pages: | | | | | | | |
| Claims: | | | | | | | |
| Miscellaneous-Filing: | | | | | | | |
| Petition: | | | | | | | |
| Patent-Appeals-and-Interference: | | | | | | | |
| Post-Allowance-and-Post-Issuance: | | | | | | | |
| Extension-of-Time: | | | | | | | |
| Extension - 1 month with \$0 paid | | 1251 | 1 | 130 | 130 | | |

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|-----------------------------------|----------|----------|--------|-------------------------|
| Miscellaneous: | | | | |
| Request for continued examination | 1801 | 1 | 810 | 810 |
| | Tot | 940 | | |